IN-

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

S. Patent Application

Applicant:

Masahiko Ando et al.

Serial No.:

10/500,268

Filed:

June 23, 2004

For:

Method For Eliminating Defects From

Single Crystal Silicon, And Single

Crystal Silicon

Examiner:

Felisa Carla Hiteshew

Art Unit:

1722

Confirmation No.: 9828

I hereby certify that this correspondence is being deposited with the United Postal Service as first class mail in an envelope addressed to: Mail Stop AMENDMENT, Commissioner of Patents, P.O. Box 1450, Alexandria, VA, 22313-

1450, on

November 8, 2006

Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The Office Action of August 8, 2006 has been carefully reviewed and the following amendments and remarks are made in response thereto.